

Notice of References Cited	Application/Control No. 10/676,499		Applicant(s)/Patent Under Reexamination TANNER ET AL.	
	Examiner SHEWAYE GELAGAY		Art Unit 2137	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0107691	08-2002	Kirovski et al.	704/270
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Felten et al. "Reading Between the Lines: Lessons from the SDMI Challenge" USENIX, August 13-17, 2001
	V	Cox et al. "Some general methods for tampering with watermarks" IEEE , 1998, pages 1-15
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.